**Electronic Supplementary Information** 

## Effects of the $SrTiO_3$ support on visible-light water oxidation with $Co_3O_4$ nanoparticles

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Fig. S1. SEM images of SrTiO<sub>3</sub> calcined at 1273 and 1373 K.



**Fig. S2.** Time courses of O<sub>2</sub> evolution under visible light ( $\lambda > 480$  nm) over SrTiO<sub>3</sub> (1073 K) samples modified with varying amounts of Co<sub>3</sub>O<sub>4</sub>. Reaction conditions: catalyst, 100 mg (with 200 mg La<sub>2</sub>O<sub>3</sub>); reactant solution, aqueous AgNO<sub>3</sub> (10 mM, 140 mL); light source, 300 W xenon lamp fitted with a CM-1 mirror and cutoff filters of L-42 and Y-48.



**Fig. S3.** UV-Vis-NIR diffuse reflectance spectra of rutile TiO<sub>2</sub>, SrTiO<sub>3</sub> (PC-1073 K), and BaTiO<sub>3</sub> (PC-1073 K) further modified with 2.0 wt% Co<sub>3</sub>O<sub>4</sub>.



**Fig. S4.**  $O_2$  evolution over 2.0 wt% Co<sub>3</sub>O<sub>4</sub>-loaded semiconductors (see Fig. S3) under visible light ( $\lambda > 480$  nm). Reaction conditions: catalyst, 100 mg (with 200 mg La<sub>2</sub>O<sub>3</sub>); reactant solution, aqueous AgNO<sub>3</sub> (10 mM, 140 mL); light source, 300 W xenon lamp fitted with a CM-1 mirror and cutoff filters of L-42 and Y-48.

<b>Table S1.</b> Dependence of the O <sub>2</sub> evolution ra	te over 2.0 wt% Co <sub>3</sub> O <sub>4</sub> -loaded SrTiO <sub>3</sub> (1073 K) on the
incident light cutoff wavelength <sup>a</sup>	

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Entry	Wavelength of incident light / nm	Rate of $O_2$ evolution / $\mu$ mol h <sup>-1</sup>
1	480 <	2.0
2	600 <	1.3
3	720 <	0.7
4	800 <	0.4
5	850 <	N.D.

<sup>*a*</sup> Reaction conditions: catalyst, 100 mg (La<sub>2</sub>O<sub>3</sub> 200 mg); reactant solution, aqueous AgNO<sub>3</sub> (10 mM, 140 mL); light source, 300 W xenon lamp fitted with a total reflection mirror, a L-42 cutoff filter and another cutoff filter. Here an output current of xenon lamp was 10 A.